

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAWAGUCHI et al

Serial No.: (not yet assigned)

Filed: October 21, 2003

For: PLASMA PROCESSING METHOD AND APPARATUS

Group: 1765

Examiner: S. Ahmed

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

October 21, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Title and Specification;

Amendment to the Abstract;

Amendments to the Claims; and

Remarks are included following the amendments.